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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | LI et al. | Examiner: | Unassigned |
| Serial No.: | 10/671,085 | Group Art Unit: | 1762 |
| Filed: | September 25, 2003 | Docket No.: | HSJ920030110US1 (HITG.040PA) |
| Title: | METHOD FOR FORMING A READ TRANSDUCER BY ION MILLING AND CHEMICAL MECHANICAL POLISHING TO ELIMINATE NONUNIFORMITY NEAR THE MR SENSOR | | |

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 16, 2005.

By: Kathleen M. DeVitt
Kathleen McDevitt

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Kindly advise the undersigned of the present status of this application, and please indicate when a communication from the U.S. Patent and Trademark Office may be expected.

Respectfully submitted,

CRAWFORD MAUNU PLLC
1270 Northland Drive
Suite 390
St. Paul, MN 55120
(651) 686-6633

Date: March 15, 2005

David W. Lynch
David W. Lynch
Reg. No. 36,204